Docket No.: O11.2I-13210-US01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Tsuyoshi MATSUDA; Tatsuhiko HIRANO; Junhui

OH; Atsunori KAWAMURA; Kenji SAKAI

Application No.:

Not Assigned

Filed:

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For:

POLISHING COMPOSITION AND POLISHING

METHOD

Group Art Unit:

Not Assigned

Mail Stop PCT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Before beginning examination and calculating the fees in this application, please amend the above-identified application as indicated below:

PRELIMINARY AMENDMENT